IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No	932,040
Priority Filing Date August 1	6, 2001
Inventor	ennison
Assignee Micron Technology	ogy, Inc.
Priority Group Art Unit	2825
Priority Examiner	chegiani
Attorney's Docket No	22-2346
Title: Semiconductor Processing Methods, and Semiconductor Assemblies	

INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, copending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09/932,040, filed August 16, 2001, upon which the above-identified application relies for a priority date under 35 U.S.C. §120. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. §1.98(d) and MPEP §609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 7-29-03

D. Brent Kenady Reg. No. 40,045

Sheet 1 of 1 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE ATTY. DOCKET NO. MI22-2346 SERIAL NO. Form PTO-1449 Filed Herewith APPLICANT LIST OF ART CITED BY APPLICANT Charles H. Dennison (Use several sheets if necessary) GROUP FILING DATE U.S. PATENT DOCUMENTS Class Subclass Filing Date Date Name Document *Examiner If Appropriate Number Initial $\mathbf{A}\mathbf{A}$ 5,742,555 04/98 Marr et al. ΑB 6,154,398 11/00 Cutter et al. AC 6,081,021 06/00 Gambino et al. 5,171,715 12/92 Husher et al. AD 05/92 Lowrey et al. ΑE 5,110,754 ΑF 5,674,787 10/97 Zhao et al. AG 5,233,217 08/93 Dixit et al. 10/02 Brintzinger et al. 6,458,631 B1 ΑH 09/00 Shao et al. ΑI 6,124,194 6,335,228 B1 01/02 Fuller et al. ΑJ ΑK 5,780,323 07/98 Forouhi et al. FOREIGN PATENT DOCUMENTS Class Subclass Translation Country Date Document Number No Yes ΑL AM ΑN ΑO ΑP OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) AR AS

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include

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EXAMINER